



**ELECTRONIC COPY**

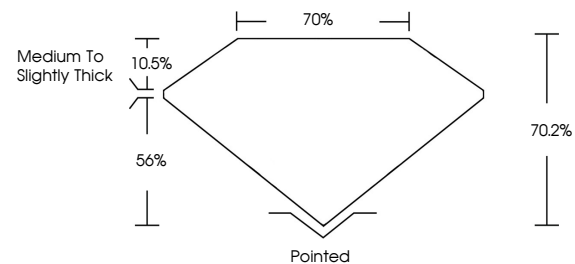
LG784670416  
Report verification at igi.org



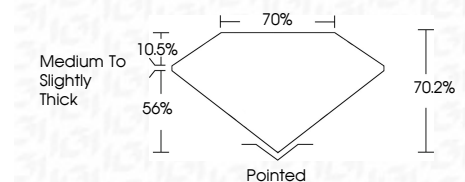
March 24, 2026  
IGI Report Number **LG784670416**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **6.87 X 6.75 X 4.74 MM**  
**GRADING RESULTS**  
Carat Weight **1.90 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

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**PROPORTIONS**



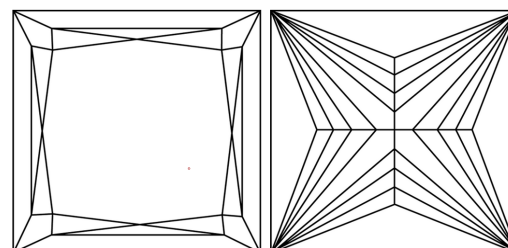
Sample Image Used



**GRADING RESULTS**

Carat Weight **1.90 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

**CLARITY CHARACTERISTICS**



**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784670416**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
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Inscription(s) **IGI LG784670416**

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March 24, 2026  
IGI Report No **LG784670416**  
**PRINCESS CUT**  
**6.87 X 6.75 X 4.74 MM**  
Carat Weight **1.90 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **70.2%**  
Table **70%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784670416**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa